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Bib Data Sheet

CONFIRMATION NO. 6868

<b>SERIAL NUMBER</b> 09/616,395	<b>FILING DATE</b> 07/14/2000 <b>RULE</b>	<b>CLASS</b> 257 43E	<b>GROUP ART UNIT</b> 2811 2813	<b>ATTORNEY DOCKET NO.</b> P97,0027 01
<b>APPLICANTS</b> Hiroshi Tayanaka, Kanagawa, JAPAN;				
<b>** CONTINUING DATA *****</b> THIS APPLICATION IS A CIP OF 08/818,239 03/14/1997 PAT 6,107,213 OK K WHICH IS A CIP OF 08/595,382 02/01/1996 PAT 5,811,348				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN P07-037655 02/02/1995 JAPAN P08-061552 03/18/1996 OK K JAPAN P08-234480 09/04/1996				
<b>IF REQUIRED, FOREIGN FILING LICENSE</b>				
<b>GRANTED ** 09/05/2000</b>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 28	<b>TOTAL CLAIMS</b> 4  <b>INDEPENDENT CLAIMS</b> 4
Verified and Acknowledged Examiner's Signature <i>K. Chen</i> Initials				
<b>ADDRESS</b>				
#6 <del>DAVID R. METZGER</del> SONNENSCHN NATH & ROSENTHAL P.O. BOX #061080 WACKER DRIVE STATION, SEARS TOWER CHICAGO, IL 60606-1080				
<b>TITLE</b>				
Thin film semiconductor and method for making thin film semiconductor				
<b>FILING FEE RECEIVED</b> 768	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	